



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

| In re Application of: |) |
|---|--------------------------|
| Goro NAKATANI et al. |) Confirmation No.: 4701 |
| Application No.: 10/043,276 |) Group Art Unit: 2811 |
| Filed: January 14, 2002 | Examiner: Junghwa M. Im |
| For: SEMICONDUCTOR DEVICE AND METHOD FOR MANUFACTURING THE SAME |) Mail Stop RCE) |

Mail Stop RCE

Commissioner for Patents Customer Window Alexandria, VA 22314

Sir:

AMENDMENT FOE ENTRY WITH RCE

In response to the Final Office Action dated January 28, 2008 (Paper No. 20080111), the period for reply to which has been extended to May 28, 2008, by a petition for a one-month extension of time filed concurrently herewith, please amend the above-identified RCE application as follows: